

RECEIPT

**PATENT** 

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Tan et al.

Serial No.: 10/645,389

**Filed:** August 21, 2003

For: APPARATUS, SYSTEMS AND METHODS RELATING TO THE RECONSTRUCTION OF SEMICONDUCTOR WAFERS FOR WAFER-LEVEL PROCESSING AND RECONSTRUCTED SEMICONDUCTOR WAFERS

Confirmation No.: 8099

**Examiner:** 

Group Art Unit: 2812

Attorney Docket No.: 2269-5528US

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents,

P.O. Box 1450, Alexandria, VA 22313-1450:

December 10, 2003

Date

Shirley Dougherty

Name (Type/Print)

## REQUEST FOR CORRECTED FILING RECEIPT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Attached is a copy of the official filing receipt received from the PTO in the above application. Issuance of a corrected filing receipt in accordance with the annotations on the attached filing receipt copy is respectfully requested.

The errors to be corrected are as follows:

The applicants are Yong Kian Tan and Wuu Yean Tay.

Serial No.: 10/645,389

These corrections are not due to any errors by Applicants and no fee is due.

Respectfully submitted,

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Date: December 10, 2003

BLC/sdd

Enclosure: Copy of Official Filing Receipt with annotations correcting errors

Document in ProLaw



24247

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FILING OR 371 ART UNIT **FIL FEE REC'D** APPL NO. ATTY.DOCKET NO DRAWINGS TOT CLMS IND CLMS (c) DATE 1476 10/645,389 08/21/2003 2812 5528US (02-1052.00/US) 51 5 10

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CONFIRMATION NO. 8099

NOV 1 9 2003

FILING RECEIPT

Trask Britt

\*OC000000011284925\*

Date Mailed: 11/17/2003

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Kian Tan Yong, Residence Not Provided; YONG KIAN TAN WUU YEAN TAY

Domestic Priority data as claimed by applicant

Foreign Applications

SINGAPORE 200302784-4 07/05/2003

If Required, Foreign Filing License Granted: 11/15/2003

Projected Publication Date: To Be Determined - pending completion of Missing Parts

Non-Publication Request: No

Early Publication Request: No

Title

Apparatus, systems and methods relating to the reconstruction of semiconductor wafers for wafer-level processing and reconstructed semiconductor wafers

**Preliminary Class** 

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